

**Notice of References Cited**

Application/Control No.

10/005,803

Applicant(s)/Patent Under  
Reexamination  
SHIH ET AL.

Examiner

Kin-Chan Chen

Art Unit

1765

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,323,121	11-2001	Liu et al.	438/633
	B	US-6,503,840	01-2003	Catabay et al.	438/694
	C	US-6,204,192	03-2001	Zhao et al.	438/723
	D	US-6,436,808	08-2002	Ngo et al.	438/623
	E	US-6,465,352	10-2002	Aoki, Hidemitsu	438/689
	F	US-6,114,259	09-2000	Sukharev et al.	438/789
	G	US-6,153,530	11-2000	Ye et al.	438/720
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.